

12/11/01
Case No. 00CT18953324
TO: DIRECTOR,
U.S. PATENT AND TRADEMARK OFFICE
WASHINGTON, DC 20231

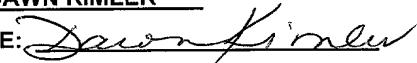
Transmitted herewith for filing is the patent application of:

12-14-01
A
I HEREBY CERTIFY THIS PAPER OR FEE IS BEING DEPOSITED WITH THE U.S. POSTAL SERVICE "EXPRESS MAIL POST OFFICE TO ADDRESSEE" SERVICE UNDER 37 CFR 1.10 ON THE DATE INDICATED BELOW AND IS ADDRESSED TO: BOX PATENT APPLICATIONS, ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231.

EXPRESS MAIL NO: EL768537454 US

DATE OF DEPOSIT: December 11, 2001

NAME: DAWN KIMLER

SIGNATURE: 

Inventors: COFFA, Salvatore
OCCHIPINTI, Luigi

For: PRESSURE SENSOR MONOLITHICALLY INTEGRATED AND
RELATIVE PROCESS OF FABRICATION

Please Note the Following:

Patent Application: 15 pages, 8 claims
4 sheets of drawings
The suggested drawing figure to be published is FIG. 3h.
Citation Under 37 CFR 1.97 and PTO-1449
A Preliminary Amendment
Submission of Proposed Drawing Modification.
A certified copy of an Italian application.
Assignee info:
Name: STMicroelectronics S.r.l.
Address: Via C. Olivetti, 2, 20041 Agrate Brianza, Italy
Country of Incorporation: Italy
 Applicant claims priority benefit to the following foreign application(s):
Country: Italy
Application No.: VA 2000A000042
Filing Date: December 15, 2000

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JC503 U.S. PTO
10/014880

The Declaration and Filing Fee are **NOT** ENCLOSED.

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